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PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SMITHER, Robert K.
Application: HIGH SPATIAL RESOLUTION X-RAY GAMMA RAY IMAGING
SYSTEM USING CRYSTAL DIFFRACTION LENSES
Serial Number: 10/775,789
Filing Date: February 10, 2004
Art Unit: 2882
Examiner: KAO, Chih Cheng G.
Atty. Docket: 0003/01475

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail, pursuant to 37 C.F.R. § 1.8 addressed to: Mail Stop: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 7/29/2005 (Date of Deposit).

Heather Cruz-Santiago
Name of Representative

Heather Cruz-Santiago
Signature

7/29/05
Date of Signature

Mail Stop: Amendment
Commissioner for Patents
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Chicago, IL 60606
312-621-1330

LETTER TO THE OFFICIAL DRAFTSPERSON

Dear Sir or Madam:

In response to the May 3, 2005, Office Action transmitted herewith are eight sheets of annotated and replacement drawings for figures 5a-5b, 6, 7, 13-14, and 15a-15b. Applicant hereby submits said drawing as replacement sheets to rectify the May 3, 2005 objections made by the Examiner.

No new matter has been added to this formal drawing.

Respectfully submitted,

CHERSKOV & FLAYNIK

By Michael J. Cherskov
Michael J. Cherskov (Reg. No 33,664)